

Search Notes	Application/Control No.	Applicant(s)/Patent Under Reexamination
	10551514	VAN DER WIEL, APPOLONIUS H. JACOBUS
	Examiner	Art Unit
	Hsien-ming Lee	2823

SEARCHED

Class	Subclass	Date	Examiner
438	25,26,55	4/30/09	HL
73	861.355,861.356,861.357	4/30/09	HL

SEARCH NOTES

Search Notes	Date	Examiner
EAST (USPAT, USPG, USOCR, EPO, JPO, IBM, Derwent)	4/30/09	HL

INTERFERENCE SEARCH

Class	Subclass	Date	Examiner

	/Hsien-ming Lee/ Primary Examiner, Art Unit 2823
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